

Notice of References Cited	Application/Control No. 10/826,221	Applicant(s)/Patent Under Reexamination BERDAN, CLARKE	
	Examiner Daniel J. Colilla	Art Unit 2854	Page 1 of 1

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	U	Machine translation of JP 2001232700 to Kitamura et al. from Japanese Patent Office website.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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